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PATENT

A

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of: : Atty Docket: 97-CCP-251 DIV
Eric GERRITSEN et al. : APPLICATIONS BRANCH
Serial No.: (not yet assigned) :
Filed: Herewith :

For: *PROCESS FOR FORMING A LOW RESISTIVITY TITANIUM
SILICIDE LAYER ON A SILICON SEMICONDUCTOR SUBSTRATE
AND THE RESULTING DEVICE*

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☒ Specification and formal drawings
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